

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of :
Shunji Hayashi : Attn: Applications Branch
Continuation of Serial No.: 10/206,067 : Attorney Docket No. SKI.008C2
Filed: November 14, 2003 :
For: METHOD AND SYSTEM FOR MANAGING SEMICONDUCTOR
MANUFACTURING EQUIPMENT

PRELIMINARY AMENDMENT

U.S. Patents and Trademark Office
2011 South Clark Place
Customer Window, **Mail Stop Patent Application**
Crystal Plaza Two, Lobby, Room 1B03
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Date: November 14, 2003

Sir:

Preliminary to the examination of the above-identified application, please enter the following amendments and remarks.

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 3 of this paper.

Remarks/Arguments begin on page 8 of this paper.